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## Search Results - Record(s) 1 through 12 of 12 returned.

## 1. Document ID: US 5441599 A

L19: Entry 1 of 12

File: USPT

Aug 15, 1995

US-PAT-NO: 5441599

DOCUMENT-IDENTIFIER: US 5441599 A

TITLE: Lightly doped drain etch method for semiconductor manufacture

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Draw Desc	Image
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## 2. Document ID: US 5390785 A

L19: Entry 2 of 12

File: USPT

Feb 21, 1995

US-PAT-NO: 5390785

DOCUMENT-IDENTIFIER: US 5390785 A

TITLE: Pressurized sealable transportable containers for storing a semiconductor wafer in a protective gaseous environment

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Draw Desc	Image
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## 3. Document ID: US 5311060 A

L19: Entry 3 of 12

File: USPT

May 10, 1994

US-PAT-NO: 5311060

DOCUMENT-IDENTIFIER: US 5311060 A

TITLE: Heat sink for semiconductor device assembly

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Draw Desc	Image
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## 4. Document ID: US 5259254 A

L19: Entry 4 of 12

File: USPT

Nov 9, 1993

US-PAT-NO: 5259254

DOCUMENT-IDENTIFIER: US 5259254 A

TITLE: Sample introduction system for inductively coupled plasma and other gas-phase, or particle, detectors utilizing ultrasonic nebulization, and method of use

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Draw Desc	Image
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## 5. Document ID: US 5256235 A

L19: Entry 5 of 12

File: USPT

Oct 26, 1993

US-PAT-NO: 5256235

DOCUMENT-IDENTIFIER: US 5256235 A

TITLE: Method for forming long thin flexible laminates

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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## 6. Document ID: US 5252700 A

L19: Entry 6 of 12

File: USPT

Oct 12, 1993

US-PAT-NO: 5252700

DOCUMENT-IDENTIFIER: US 5252700 A

TITLE: Heat-resistant adhesive and method of adhesion by using adhesive

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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## 7. Document ID: US 5161465 A

L19: Entry 7 of 12

File: USPT

Nov 10, 1992

US-PAT-NO: 5161465

DOCUMENT-IDENTIFIER: US 5161465 A

TITLE: Method of extending the useful life and enhancing performance of lithographic printing plates

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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## 8. Document ID: US 5135779 A

L19: Entry 8 of 12

File: USPT

Aug 4, 1992

US-PAT-NO: 5135779

DOCUMENT-IDENTIFIER: US 5135779 A

TITLE: Method for conditioning an organic polymeric material

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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## 9. Document ID: US 4894421 A

L19: Entry 9 of 12

File: USPT

Jan 16, 1990

US-PAT-NO: 4894421  
 DOCUMENT-IDENTIFIER: US 4894421 A  
 TITLE: Low-crystalline propylene random copolymer composition, process for production thereof, and polypropylene composite laminated structure

[Full](#) | [Title](#) | [Citation](#) | [Front](#) | [Review](#) | [Classification](#) | [Date](#) | [Reference](#) | [Claims](#) | [KMC](#) | [Draw Desc](#) | [Image](#)

**10. Document ID: US 4529651 A**

L19: Entry 10 of 12

File: USPT

Jul 16, 1985

US-PAT-NO: 4529651  
 DOCUMENT-IDENTIFIER: US 4529651 A  
 TITLE: Magnetic recording medium having organic protective overlayer

[Full](#) | [Title](#) | [Citation](#) | [Front](#) | [Review](#) | [Classification](#) | [Date](#) | [Reference](#) | [Claims](#) | [KMC](#) | [Draw Desc](#) | [Image](#)

**11. Document ID: US 3789321 A**

L19: Entry 11 of 12

File: USPT

Jan 29, 1974

US-PAT-NO: 3789321  
 DOCUMENT-IDENTIFIER: US 3789321 A  
 TITLE: ELECTRON BEAM-PUMPED GAS LASER SYSTEM

[Full](#) | [Title](#) | [Citation](#) | [Front](#) | [Review](#) | [Classification](#) | [Date](#) | [Reference](#) | [Claims](#) | [KMC](#) | [Draw Desc](#) | [Image](#)

**12. Document ID: US 3686374 A**

L19: Entry 12 of 12

File: USPT

Aug 22, 1972

US-PAT-NO: 3686374  
 DOCUMENT-IDENTIFIER: US 3686374 A  
 TITLE: GAS ASSISTED ELECTROSTATIC PINNING

[Full](#) | [Title](#) | [Citation](#) | [Front](#) | [Review](#) | [Classification](#) | [Date](#) | [Reference](#) | [Claims](#) | [KMC](#) | [Draw Desc](#) | [Image](#)

**Generate Collection**

Terms	Documents
('3686374' '5135779' '5390785' '5252700' '5256235' '4529651' '3789321' '5441599' '5311060' '5161465' '4894421' '5259254')[PN]	12

**Display**

50

Documents, starting with Document: 12

**Display Format:** TI  **Change Format**

## Search History

Today's Date: 7/12/2000

### DB Name

DB Name	Query	Hit Count	Set Name
USPT	l62 and l63	0	
USPT	l60 and l37	22	L64
USPT	l30 and l61	2	L63
USPT	l60 and l39	265	L62
USPT	l59 and technology.asp.	272	L61
USPT	l45 and micron.asp.	291	L60
USPT	(MICRONTECHNOLOGY   MICRONTECHNOLOGY-INC)!	1	L59
USPT	(MICRONTECHNOLOGY   MICRONTECHNOLOGY-INC)!	1	L58
USPT	l55 and l37	7	L57
			L56

USPT	I54 and I34	38
USPT	I53 and I30	143
USPT	I39 same I52	8036
USPT	gas with substrate	24881
USPT	I48 and I30	2
USPT	I48 and I30	2
USPT	I48 and seal\$	10
USPT	I39 and I47	82
USPT	I45 and I6 and (I7 or I8)	84
USPT	(156/643   156/643-642   156/643E   156/643-646   156/643-659   "156/643.07"   "156/643.1"   "156/643.11"   "156/643.7")!	7778
USPT	(156/643   156/643-642   156/643E   156/643-646   156/643-659   "156/643.07"   "156/643.1"   "156/643.11"	L46

"156/643.7")!

USPT	7778	1.45
	0	
USPT	1.44	
	0	
USPT	1.43	
	0	
USPT	140 and ((156/643 )!.CCLS. )	1.42
	0	
USPT	((156/643 )!.CCLS. )	0
	0	
USPT	138 and 139	L41
	658	
USPT	L40	
	380691	
USPT	(semiconduct\$ or semi-conduct\$ or electrod\$)	L39
	1515	
USPT	130 and 137	L38
	1515	
USPT	136 or 111 or 114 or 113	41769
	L37	
USPT	caption	
	157	
USPT	L36	
	1	
USPT	133 and 134	L35
	micron or micrometer or micromiter	

200209  
USPT L34  
132 and (113 or 114 or 111)  
9  
USPT L33  
131 and (15 or 16)  
39  
USPT L32  
130 and (17 or 18)  
54  
USPT L31  
heat\$.clm. and transfer\$.clm.  
32586  
USPT L30  
127 and 128  
1  
USPT L29  
seal.clm.  
93342  
USPT L28  
126 and (15 or 16)  
59  
USPT L27  
125 and (111 or 114)  
59  
USPT L26  
(16 or 17) and (semiconduct\$ or semi-conduct\$ or conduct\$).ti.ab.clm.  
1327  
USPT L25  
('5390785' '5311060' '5259254' '5161465')[PN]  
4  
USPT L24  
body.clm or hold\$.clm. or held.clm. or clamp.clm.  
346092

USPT		L23
	('4726879' '4676867')[PN]	2
USPT		L22
	6 and ( 7 or  8) and ( 11 or  13 or  14)	21
USPT		L21
	18 and (semiconduct\$ or semi-conduct\$ or conduct\$).ti,ab,clm.	10
USPT		L20
	('3686374' '5135779' '5390785' '5252700' '5256235' '4529651' '3789321' '5441599' '5311060' '5161465' '4894421' '5259254')[PN]	12
USPT		L19
	11 and  6	23
USPT		L18
	12 and  6	0
USPT		L17
	12 or  15	594
USPT		L16
	( 7 or  8) and  14	580
USPT		L15
	polyimide or poly-imide	39728
USPT		L14
	polyimide	39708
USPT		L13
	11 and ( 7 or  8)	

USPT	kapton	42	L12
USPT	18 and 15	4489	L11
USPT	18 and 16	2134	L10
USPT	plasma.clm. and etch\$.clm.	122	L9
USPT	plasma.clm. and ethch\$.clm.	4394	L8
USPT	helium.clm or he.clm.	1	1.7
USPT	gas\$.clm.	8128	L6
USPT	((118 or 216 or 204 or 438).Clas. )	211305	L5
USPT	((118 or 216 or 204 or 438/ )!.Clas. )	0	L4
USPT	((118 or 216 or 204 or 438/ )!.CCLS. )	0	L3